

		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY DOCKET NO JM32810-CIP	SERIAL NO 10,046,330		
		LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)		APPLICANT Wuwen Yi et al			
				FILING DATE October 25, 2001	PRIORITY GROUP 2818		
		U.S. PATENT DOCUMENTS					
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
PD	AA	6,214,177 B1	04/01	Runkle	—	—	
	AB	5,294,321	03/94	Satou et al	—	—	
	AC	5,612,571	03/97	Satou et al	—	— C	
	AD	5,464,520	11/95	Kano et al	—	—	
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	AF	6,033,537	03/00	Suguro	—	—	
	AG	5,955,685	09/99	Na	—	— C	
	AH	5,415,829	05/95	Ohhashi et al	—	—	
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PD	AK	5,320,729	06/94	Narizuka et al	—	—	
	AL						
FOREIGN PATENT DOCUMENTS							
		Document Number	Date	Country	Class	Subclass	Translation
							Yes
	AM						No
	AN						
	AO						
	AP						
	AQ						
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)							
	AR						
	AS						
EXAMINER PHUC T DANG				DATE CONSIDERED 2/15/2003			
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